



NIP-214

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

T. SEKI et al

Serial No. 09/756,922

Group Art Unit: 2881

Filed: January 10, 2001

Examiner: B. Anderson

For: ION IMPLANTATION EQUIPMENT AND
IMPLANTATION METHOD THEREOF

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Final Rejection) mailed March 27, 2003, please amend the above-identified application as follows. A Petition and fee for a two-month Extension of Time accompanies this response.